ELECTRICAL AND THERMOELECTRIC POWER PROPERTIES OF Cd₂₃Se₄₃S₃₄

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Electrical conductivity, I-V characteristics and thermoelectric power are investigated for $Cd_{23}Se_{43}S_{34}$ film sample as a function of temperature and thickness. D.C conductivity increases with temperature, while it increases with increasing film thickness. The obtained results showed that the conduction activation energy has two values ΔE_{σ} and

 ΔE_{σ_2} indicating the presence of two different conduction mechanisms through the investigated range of temperature (327-400K). The thermo-power (TEP) measurements carried out using differential dc method in the temperature range (322-370K) and the activation energy ($\Delta E_{\rm s}$) for TEP determined. Positive thermoelectric power suggests a large predominance of holes in electrical transport. The I-V characteristics of films are typical for a memory switch. The mean value of the threshold voltage $V_{\rm th}$ decreases with increasing temperature and increases with increasing film thickness. The switching voltage activation energy (ϵ) was determined. Agreement between the obtained value of ratio ($\epsilon/\Delta E_{\sigma_2}$) with its values obtained theoretically on the basis of an electrothermal model was found.

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1. Introduction

Semiconducting glasses, namely Chalcogenide glasses, contain one or more of the Chalcogenide elements (group VI elements S, Se, Te) as alloy elements. They behave as semiconductors, more precisely; they exhibit amorphous semiconductor behavior with band gap energy from 1 to 3 eV. Chalcogenide glasses have received a lot of attention because they provide solid state physicists with new challenging fundamental problem and because of their possible technological applications [1, 2].

Certain amorphous semiconductors have shown interesting electrical effects involving a sudden change in resistance; these are generally grouped as switching properties. Typical materials which show these properties are the Chalcogenide glasses [3]. It is now more than two decades since the first demonstration of switching and memory devices, based on Chalcogenide glasses, was reported by Ovshinsky [4].

In this work, the electrical conductivity, thermoelectric power and I-V characteristics of amorphous $Cd_{23}Se_{43}S_{34}$ films deposited on glass and pyrographite substrates were studied as a function of temperature and film thickness.

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2. Experimental

Glassy alloy of Cd₂₃Se₄₃S₃₄ was prepared by quenching technique. High purity (99.999%) materials are weighted according to their atomic percentage, and sealed in dry silica tube under a vacuum of 10⁻⁵ torr. The ampoule is placed in the stable zone of an oscillatory furnace.

The ampoule temperature was raised to 119°C (m.p. of S) and kept constant for 2h, then it was raised to 220°C (m.p of Se) and kept constant for 2h, also it was raised to 320°C (m.p of Cd) and kept constant for 2h and finally it was raised to 700°C and kept constant for 6h. The oscillation of the tube was necessary to ensure homogenization of the composition obtained. The melt was quenched in ice-water.

Films with different thicknesses of $Cd_{23}Se_{43}S_{34}$ were obtained by thermal evaporation under vacuum (10^{-6} torr using coating unit) on glass substrates for electrical and thermoelectric power measurements, and high polished pyrographite substrates for switching measurements. Film thickness was measured by Tolansky's interferometric method [5].

X-ray analysis was used to investigate the structure of the obtained material in film whose chemical composition was checked by energy dispersive analysis of X-ray (EDAX) (National Center of Radiation Research and Technology, Cairo, Egypt).

The two-probe method was used to measure the electrical conductivity, Ag metal used for electrodes. A digital electrometer (keithley type 617A) using to measure the resistance of the film. A Chromel-Alumel thermocouple is fixed to the midpoint of the sample substrate to measure the film temperature.

Especially sample holder was used for the thermoelectric power measurements. The Al electrodes were deposited over the glass substrate to be used as electrodes. Differential heater, (keithley type E 617A) used to measure the voltage (ΔV) across the sample resulting from the applied temperature gradient; the temperature difference (ΔT) between the limits of the sample was measured by two calibrated Chromel-Alumel thermocouple mounted near the two electrodes.

Measurements of the current-voltage characteristics were carried out in a measuring cell fitted with two electrodes [6]. The lower one was made of copper in contact with the pyrographite substrate with dimensions ($1.5\times0.8\times0.1~\text{cm}^3$). The upper electrode was a movable platinum wire a thin circular and its diameter $\approx 200~\mu n$. Measurements were carried out using highly stabilized power supply (0-400 volt), a digital electrometer (Keithley type E617A) was used for the potential drop measurements and sensitive multimeter was used for the current measurements.

The experimental error during measurements was approximately $\pm 2\%$.

3. Results and discussion

3.1 Structural properties:

Fig. (1) shows the X-ray diffraction patterns for the investigated compositions Cd_{23} Se_{43} S_{34} film with two thickness $\approx (600,700 \text{ nm})$ as representative example. Detailed examination of the X-ray patters indicate that all the films are amorphous with two main diffraction humps located at the same positions.

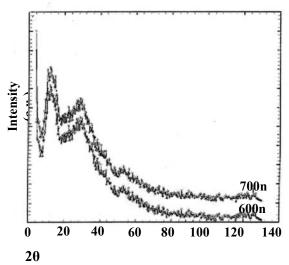
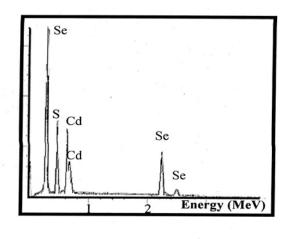


Fig. 1. The X-ray diffraction pattern for $Cd_{23}Se_{43}S_{34}$ film.

The composition of the investigated films was checked using energy dispersive X-ray analysis (EDX). The obtained percentages of their constituent elements are illustrated in Fig (2). They are close to the prepared compositions. Moreover, EDX analysis indicates the absence of impurities elements in the studied compositions.



Cd₂₃Se₄₃S₃₄

Fig. (2): The chemical composition of the obtained films is checked by (EDAX) energy dispersive analysis of X-ray Cd₂₃Se₄₃S₃₄.

3.2 Electrical properties:

The variation of electric conductivity σ with the reciprocal temperature in the temperature range (327-400K) for a Cd₂₃Se₄₃S₃₄ films is displayed in Fig.(3) for films of different thickness in the range \approx (200-700 nm). For all films, the electrical conductivity was found to be anegative exponential function of the absolute temperature according to the following relation [7].

$$\sigma = \sigma_0 \exp\left(-\Delta E_{\sigma}/k_B T\right),\tag{1}$$

where σ_0 is the pre-exponential factor included charge carrier mobility and density of states, k_B the Boltzmaan's constant, T the absolute temperature and ΔE_{σ} the activation energy for conduction. As observed in Fig.(3) each obtained relation consists of two linear parts corresponding to lower (327-370K) and I

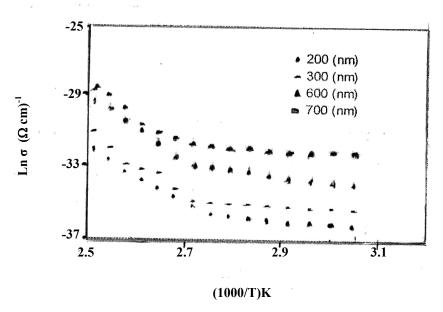


Fig. (3): Temperature dependence of the electrical conductivity for the composition Cd₂₃Se₄₃S₃₄.

The presence of two linear regions in the ln σ vs 1000/T plots is most likely due to the appearance of two conduction mechanism.

Values of σ_{RT} (room temperature conductivity) and σ_{01} for the investigated films with different thickness that estimated from Fig.(3) are given in Table 1. It is observed that the electrical conductivity at any temperature as well as σ_{RT} and σ_{01} increase with increasing film thickness in the investigated range $\approx (200\text{-}700 \text{ nm})$, which may be attributed to decrease in the degree of disorder and defects present in the structure [8] ΔE_{σ_2} and ΔE_{σ_1} are thickness slightly independent with values ≈ 0.97 and 0.12 eV for higher and lower temperature regions, respectively, since observed measured relations are parallel.

Table 1

Thickness(nm)	σ_{RT} $(\Omega \text{ cm})^{-1}$	$(\Omega \text{ cm})^{-1}$
200	9.2166E ⁻¹⁵	1.1
300	1.0877E ⁻¹⁵	1.13
600	2.1536E ⁻¹⁴	1.15
700	1.7241E ⁻¹³	.1.17

3.3 Thermoelectric power properties

The general expression for thermoelectric power (TEP) in the case of amorphous semiconductors has been discussed extensively in the literature [9,10]. In the case where carriers are excited to appropriate extended states beyond the mobility edges, or where charge carriers form small polarons and are transported by hopping near the band edges the expressions for TEP are formally identical. S is given by [10].

$$S = \pm \left(\frac{k}{e}\right) \left[\left(\frac{\Delta E_S}{k_B T}\right) + A\right] \tag{2}$$

$$\Delta E_s = (E_F - E_V) \quad \text{or} \quad (E_C - E_F) \tag{3}$$

where A is the small constant between 1 and 4[9] and represents the thermal energy transported by the carriers. Its magnitude is, therefore, dependent on the nature of the scattering processes. As already mentioned, ΔE_s may be, in general, lower than ΔE_{σ_2} and this difference is considered as equal to the mobility activation energy [9] or to the polaron-hopping barrier if the conduction is by small polarons [11].

Figure (4) gives the temperature dependence of the thermo-electric power (S) for thin films of $Cd_{23}Se_{43}S_{34}$ at different temperature. As can be seen from Fig.(4) the (S) vs. 1000/T graphs are straight lines with a positive slope indicating that (S) decreases linearly with temperature. The activation energy (ΔE_s) has been calculated by using the slopes of Fig.(4) with value 0.73 eV, since observed measured relations are parallel. The temperature dependence of thermoelectric power (S) measures the energy difference between the Fermi level and the energy where charge transport occurs.

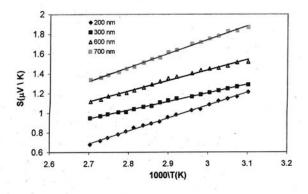


Fig. (4): The temperature dependence of the thermoelectric power for the compositions Cd₂₃Se₄₃S₃₄.

In a simple one-band model with the Fermi energy pinned near the middle of the band gap, S is thermally activated with the activation energy of the carrier density activation energy. The difference between ΔE_{σ_2} and ΔE_s (0.23eV) can be attributed to a mobility activation energy. The small polarns near the band edges may also contribute to the conductivity. These small polarons are usually associated with the structure of Se [12]. This results is in agreement with earlier estimates [13-15].

3.4 I-V characteristics:

I-V characteristics curves were studied for $Cd_{23}Se_{43}S_{34}$ films of different thickness in the thickness range $\approx (200,700 \text{ nm})$ at different temperature in the temperature range (323-353K). Fig.(5) shows room temperature I-V characteristics for $Cd_{23}Se_{43}S_{34}$ film with thickness 700nm as a representative example. It is observed that on increasing the applied voltage a very small current passes through the film, representing the OFF state (with the high resistance) of the switch. At certain applied voltage (called the threshold voltage V_{th}) a sudden increase in current and drop in voltage take place. Further increase in the applied voltage increases the current passing through samples with any significant observed increase in the potential drop across sample, representing

the ON state (with low resistance). On decreasing the applied voltage, current decreases reaching zero value and if the voltage

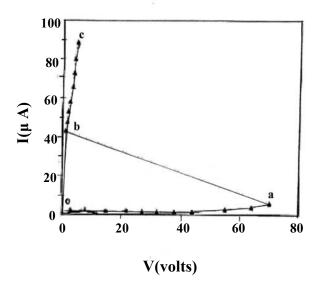


Fig (5): Static I-V characteristic curve for $Cd_{23}Se_{43}S_{34}$ thin film of thickness 700nm at room temperature.

is decreased and then increased, the I-V does not change, i.e. a permanent conduction state is established. This obtained I-V curves is typical for memory switching.

The variation of the mean value of threshold voltage V_{th} for a $Cd_{23}Se_{43}S_{34}$ films with thickness in the investigated range at room temperature was studied and illustrated in Fig.(6),

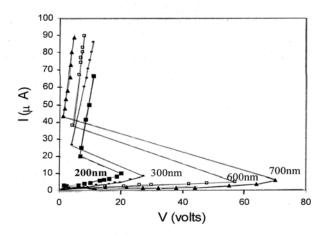


Fig (6): Static I-V characteristic curve for $Cd_{23}Se_{43}S_{34}$ film at different thickness (room temperature).

where V_{th} was measured for every film sample at different points uniformly distributed throughout the surface of the film and their mean values were calculated. A linear relationship between V_{th} and film thickness was obtained in the investigated range as in clear from fig.(6). Observed relation of thickness dependence of V_{th} agrees with previous observation for different amorphous system [14-17].

The temperature dependence of the I-V characteristics for a $Cd_{23}Se_{43}S_{34}$ films was studied in the temperature range (323-353K) for films with different thickness see from Fig.(7). The

obtained I-V characteristics are also typical for the memory switching phenomenon with values of V_{th} decreases with increasing temperature.

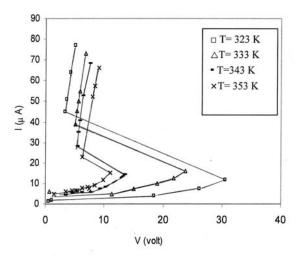


Fig (7): Temperature dependence of V_{th} for the composition Cd_{23} Se_{43} S_{34} (thickness 600 nm).

The temperature dependence of V_{th} was plotted as $\ln V_{th}$ vs 1000/T as shown in Fig.(8) for thickness 600 nm as a representative curve. The obtained parallel straight lines satisfying the following equation [18]

$$V_{th} = V_0 \exp(\varepsilon/k_B T), \qquad (2)$$

where V_0 is constant and ε the threshold voltage activation energy.

The value of ϵ that was calculated from the slope of the obtained line of Fig.(8) was found (0.49 eV)and independent on the thickness in the investigated range. The corresponding value of the ratio ($\epsilon/\Delta E_{\sigma_2}$) was calculated also using values of ΔE_{σ_2} obtained above. It is observed that the value of the ratio $\epsilon/\Delta E_{\sigma_2}$ (0.50) is in good agreement with that obtained previously [14, 15,17,19,20] for other amorphous semiconductors, as well as, with its value derived theoretically on the basis of an electrothermal model [18, 21] for the switching process.

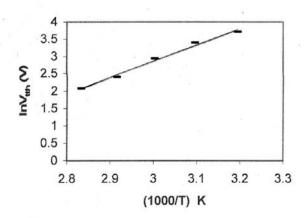


Fig (8): Plot of ln $V_{th}vs.$ (1000/T) for the compositions $Cd_{23} Se_{43} S_{34}$

So the observed temperature dependence of the threshold voltage for the pre-switching region can be explained in terms of an electrothermal model. The temperature of semiconductor is raised due to Joule heating. Since the conduction process in an amorphous material is of an

activated type [22] the conduction of the sample is thus, increased when heated. This will allow more current flow through the heated region and allow more Joule-heating resulting in further increase in the current density. Stationary state is reached when the heat lost by conduction from the current filament becomes equal to the Joule-heat generated in that region.

The electrothermal model can be solved to a certain extent by finding a stationary state solution for the heat transport equation.

$$C(dT/dt) = \sigma E^2 + \nabla (\psi \nabla T), \tag{3}$$

where C is the heat capacity, ψ is the thermal conductivity, E is the electrical field intensity (E=V_{th}/d) and σ the electrical conductivity.

In the case of steady state breakdown, the time derivative of temperature (dT/dt) can be neglected for the solution of Eq. (3). Hence, the heat conduction equation for a small difference ($\Delta T = T_m - T_s$) between the temperature at the middle of specimen T_m and that of the surface T_s gives [23].

$$8 \psi(\Delta T/d^2) + \sigma E^2 = 0.$$
 (4)

The steady state breakdown occurs when the amount of heat generated by Joule-heating cannot be removed by thermal conduction and the temperature difference necessary for breakdown can be obtained from Eqs. (3) and (4) in the form [18, 23].

$$\Delta T_{\text{breakdown}} = T^2 k_B / \Delta E.$$
 (5)

According to this equation $\Delta T_{breakdown}$ was calculated for a- $Cd_{23}Se_{43}S_{34}$ films at different temperatures, and the obtained values are given in Table 2.This results is in agreement with previous observation for different amorphous system [14,15,17] .From the above results, it can be concluded that the observed memory type switching observed in $Cd_{23}Se_{43}S_{34}$ films could be satisfactory explained according to electorthermal breakdown process.

 Temperature ,C⁰
 ΔT_{breakdown}

 30
 8.16

 40
 8.71

 50
 9.27

 60
 9.89

 70
 10.46

 80
 11.08

Table 2

4.Conclusion

 ${\rm Cd_{23}Se_{43}S_{34}}$ films were obtained by thermal evaporation technique on glass and pyrographite substrates. The obtained films are found to be of amorphous state. The electrical conductivity showed that the conduction activation energy has two values ΔE_{σ_2} and ΔE_{σ_1} which are thickness independent. I-V characteristics in ${\rm Cd_{23}Se_{43}S_{34}}$ films are typical for a memory switch. The agreement between the obtained value of the ratio $\epsilon/\Delta E_{\sigma_2}$ (0.50) and its theoretically derived value (0.5) suggested that the switching phenomenon in ${\rm Cd_{23}Se_{43}S_{34}}$ films can be explained according to an electrothermal model for the switching process.

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